

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q91743

Akihiro GOTO, et al.

Appln. No.: 10/558,384

Group Art Unit: 1745

Confirmation No.: 4167

Examiner: Not Yet Assigned

Filed: November 29, 2005

For: ELECTRODE FOR DISCHARGE SURFACE TREATMENT, MANUFACTURING METHOD FOR
ELECTRODE FOR DISCHARGE SURFACE TREATMENT, DISCHARGE SURFACE TREATMENT
APPARATUS, AND DISCHARGE SURFACE TREATMENT METHOD

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed
concurrently herewith was first cited in any communication from a foreign patent office in a
counterpart foreign application not more than three months prior to the filing of said Information
Disclosure Statement.

Respectfully submitted,



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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: March 27, 2009